

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention	METHOD FOR DETECTION OF PHOTOLITHOGRAPHIC DEFOCUS
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Application Number: 10/604610
Confirmation Number: 1609
First Named Applicant: Dennis Macaluso
Attorney Docket Number: BUR920020127US1
Art Unit: 2857
Search string: (5884242 or 5673208 or 6198982 or 6335784
or 5991004 or 5563684 or 5202748 or
20020048006 or 20010012098 or
20020097393),pn.



US Patent Documents

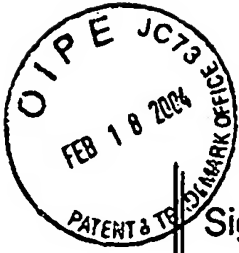
Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
<input checked="" type="checkbox"/>	1	5884242	1999-03-16	Meier et al		702	179
<input type="checkbox"/>	2	5673208	1997-09-30	Meier et al		702	179
<input type="checkbox"/>	3	6198982	2001-03-06	Soon-jong Park et al		700	121
<input type="checkbox"/>	4	6335784	2002-01-01	Kazuhiko Mishima		355	53
<input type="checkbox"/>	5	5991004	1999-11-23	Wallace et al		355	53
<input type="checkbox"/>	6	5563684	1996-10-08	Gregory J. Stagaman		355	72
<input checked="" type="checkbox"/>	7	5202748	1993-04-13	MacDonald et al		356	508

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
<input checked="" type="checkbox"/>	1	20020048006	2002-04-25	Kazuhiko Mishima		355	53
<input type="checkbox"/>	2	20010012098	2001-08-09	Kazuhiko Mishima		355	53
<input checked="" type="checkbox"/>	3	20020097393	2002-07-25	Nikoonahad et al		356	237.2



Signature

Examiner Name	Date
<i>John Se</i>	<i>01/05/04</i>